

PROCEEDINGS OF SPIE

Emerging Digital Micromirror Device Based Systems and Applications VIII

**Michael R. Douglass
Philip S. King
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Editors

**15–17 February 2016
San Francisco, California, United States**

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SPIE

Volume 9761

Proceedings of SPIE 0277-786X, V. 9761

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

Emerging Digital Micromirror Device Based Systems and Applications VIII, edited by Michael R. Douglass,
Philip S. King, Benjamin L. Lee, Proc. of SPIE Vol. 9761, 976101 · © 2016 SPIE
CCC code: 0277-786X/16/\$18 · doi: 10.1117/12.2240372

Proc. of SPIE Vol. 9761 976101-1

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Author(s), "Title of Paper," in *Emerging Digital Micromirror Device Based Systems and Applications VIII*, edited by Michael R. Douglass, Philip S. King, Benjamin L. Lee, Proceedings of SPIE Vol. 9761 (SPIE, Bellingham, WA, 2016) Six-digit Article CID Number.

ISSN: 0277-786X
ISSN: 1996-756X (electronic)
ISBN: 9781628419962

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA
Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445
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